49th INTERNATIONAL CONFERENCE ON MICROELECTRONICS, DEVICES AND MATERIALS

and the WORKSHOP on

DIGITAL ELECTRONIC SYSTEMS



CONFERENCE PROGRAM

September 25th – September 27th, 2013 Kranjska Gora, SLOVENIA

CONFERENCE MIDEM 2013 with WORKSHOP ON DIGITAL ELECTRONIC SYSTEMS

PRELIMINARY SHORT PROGRAM, Kranjska Gora September 25. - September 27, 2013

HOUR	Wodnesday 25 9 2013	Thursday 26 9 2013	Friday 27 0 2013
8:00	Wednesday, 25. 9. 2013 REGISTRATION	Thursday, 26. 9. 2013 REGISTRATION	Friday, 27. 9. 2013 REGISTRATION
8:30	OPENING CEREMONY	REGISTRATION	REGISTRATION
0.50	M. Topič		
8:45	INVITED PAPER	WORKSHOP OPENING	INVITED PAPER
0.45	Franz Dielacher	A. Žemva, A. Trost	lgor Muševič
9:00		Po Echine, Po Prost	iger meserie
2.00	Chairperson: M. Topíč	WORKSHOP INVITED PAPERS	Chairperson: M. Hrovat
9:15	charperson. m. ropic	Chairperson: A. Trost	charperson. W. movar
9:30	SESSION ON		SESSION ON
9:45	OPTOELECTRONICS	P. Bulić	THICK AND THIN FILMS
10:00		A. Biasizzo	and the second second second second
10:15	Chairperson: M. Topič	A. Biasizzo	Chairperson: M. Hrovat
10:30		COFFEE BREAK	
10:45			
11:00			
	COFFEE BREAK	WORKSHOP INVITED PAPERS	
11:15		Chairperson: A. Trost	COFFEE BREAK
11:30	SESSION ON		
11:45	MATERIALS, TECHNOLOGY	F. Brglez	SESSION ON
12:00	AND DEVICES	J. Rodrigues	INTEGRATED CIRCUITS
12:15	Chairperson: B. Malič		AND SYSTEM ON CHIP
12:30		LUNCH - 2H	Chairperson: J. Trontelj
12:45			
13:00	LUNCH - 2H		
13:15			CLOSING CEREMONY
13:30			CLOSING CLILLION
13:45			
14:00			
14:15			
14:30			
		WORKSHOP INVITED PAPERS	
14:45		Chairperson: A. Trost	
15:00	SESSION ON SENSORS		
15:15	AND MEMS	D. Strle	
15:30	Chairperson: S. Amon	Z. Brezočnik	
15:45			
16:00			
	2	COFFEE BREAK	
16:15	COFFEE BREAK	COFFEE BREAK	
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16:30		SESSION ON	
16:30 16:45	SESSION ON SENSORS AND MEMS	SESSION ON ELECTRONICS	
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ORGANIZER

MIDEM - Society for Microelectronics, Electronic Components and Materials, Stegne 7, 1000 Ljubljana, SLOVENIA

CO – ORGANIZER

Centre of Excellence NAMASTE, Jamova 39, 1000 ljubljana

CONFERENCE SPONSORS

Slovenian Research Agency, Ljubljana IMAPS, Slovenia Chapter ZAVOD TC SEMTO, Ljubljana Centre of Excellence NAMASTE, Ljubljana

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GENERAL INFORMATION

Welcome to the 49thInternational Conference on Microelectronics, Devices and Materials, (MIDEM 2013) and the joint Workshop on Digital Electronic Systems. This conference continues the tradition of annual, international meetings organized by MIDEM – Society for Microelectronics, Devices and Materials, Ljubljana, Slovenia. These conferences have always attracted a large number of Slovene and foreign experts, as well as distinguished guest speakers. At the conferences scientists have the opportunity to present their activities and research progress to the international audience and to discuss trends and problems related to their fields of work with other colleagues. This year, 43 reviewed regular papers and eight invited papers will be presented over the three days, 25 - 27 September 2013.

The standard conference contributions presented on the first and third days are grouped into six sessions: Materials, technology and devices; Electronics; Optoelectronics; Thin and Thick Films; Integrated Circuits and System on Chip and Sensors and MEMS. On the second day the work will be organised as the Workshop on Digital Electronic Systems. The distinguished speakers will talk about new approaches in low-power design, testing of programmable devices, combinatorial optimization, designing ultra-low voltage circuits, signal processing in integrated biological and chemical sensors, and model checking in formal verification.

We would like to express our thanks to the invited speakers and the contributors of regular papers for their valuable scientific contributions to the conference sessions and to the workshop. The members of the International Scientific Board of the conference, who made the review of the contributions, are gratefully acknowledged. We also thank all the Session Chairs and the members of the Conference Organizing Committee, who did their best to make the conference a success.

We hope that you will remember this event, not only for the importance of the papers and discussions, but also for the new friendships and the pleasant memories of the country.

We wish you a pleasant stay in Kranjska Gora and in Slovenia.

A. Žemva, chairman of the MIDEM Conference 2013

Kranjska Gora, September 2013



REPUBLIC OF SLOVENIA MINISTRY OF EDUCATION, SCIENCE AND SPORT





CONFERENCE VENUE

The Conference is held from September 25th to September 27th, 2013 at hotel Larix in Kranjska Gora, Slovenia.

CONFERENCE PROCEEDINGS

Invited and accepted papers are published in the Conference Proceedings distributed at the Conference registration.

LANGUAGE

The official Conference language is English.

REGISTRATION

The registration fees are as follows (VAT included)

- FULL registration fee: **300 EUR**
- MIDEM Society members, MIDEM Sponsors: 244 EUR

The fee includes Conference Proceedings and free access to all Conference events (Welcome party at Alpine Museum in Mojstrana and Conference dinner in hotel Larix).

Accompanying persons who do not take part in the conference may join other conference events at an extra charge (Welcome party: 30 EUR, Dinner: 35 EUR, additional conference materials: 100 EUR).

Undergraduate students have free access to all Conference sessions on submitting their student card / index. For other Conference events there will be an additional charge.

SOCIAL EVENTS

Welcome party at Planinski muzej (Alpine Museum) in Mojstrana is scheduled for Wednesday, September 25th at 19:00. The bus will leave in front of the hotel at 18:30. The Conference Dinner will be held on Thursday, September 26th in hotel Larix at 19:30.

ACCOMMODATION

Please send your room reservations by filling the reservation forms that are on the web page of the Society MIDEM, indicating "for MIDEM 2013 Conference", directly to:

info@hitholidays-kg.si

or call this number + 386 (0)4 588 41 00.

Programme and Organizing Committee, MIDEM 2013 Conference

Olga Zakrajšek Society MIDEM Tržaška 25 1000 Ljubljana, SLOVENIA tel. +386 (0)1 4768 319 fax. +386 (0)1 4768 130 email: olga.zakrajsek@fe.uni-lj.si Polona Šorli Society MIDEM Stegne 11 1521 Ljubljana, SLOVENIA tel. +386 (0)1 5133 767 fax. +386 (0)1 5133 771 email: polona.sorli@mikroiks.si

Contact person for the Workshop on DIGITAL ELECTRONIC SYSTEMS:

Prof. dr. Andrej Žemva - chairman

Faculty of electrical engineering Tržaška cesta 25 1000 Ljubljana, Slovenia Tel: 00386 1 4768 346 e-mail:andrej.zemva@fe.uni-lj.si Assoc. Prof. dr. Andrej Trost; cochairman and Workshop chairman Tržaška cesta 25 1000 Ljubljana, Slovenia Tel.: 00386 1 4768 350 e-mail: andrej.trost@fe.uni-lj.si

Conference Web page: http://www.midem-drustvo.si/conf2013

CONFERENCE PROGRAM

WEDNESDAY, SEPTEMBER 25

08:00 REGISTRATION

08:30 WELCOME AND OPENING CEREMONY

08:45 INVITED PAPER CHAIRPERSON: M. Topič

08:45 F. Dielacher Integrated Circuits and MMIC's for mm-Wave Transceivers

09:30 SESSION ON OPTOELECTRONICS CHAIRPERSON: M. Topič

09:30 T. Vidmar, U. Opara Krašovec, M. Topič

Inkjet Printing of Chromogenic Devices

09:45 M. Čančula, M. Ravnik and S. Žumer

Modelling Light Propagation through Optically Non-uniform Anisotropic Materials

10:00 M. Kovačič, J. Krč, B. Lipovšek and M. Topič

Diffraction Gratings for Optical Filtering in Fluorescence Detection of Biomolecules

10:15 M. Jošt, J. Krč and M. Topič Camera-based Measurement of Light Scattering Intensity Distribution

10:30 M. Sever, J. Krč and M. Topič Optical Optimisation of Periodic Surface Textures in Thin-film Silicon Solar Cells with Realistic Layer Growth Consideration

10:45 B. Kirn, K. Brecl, M. Jankovec and M. Topič

Degradation of Multi-crystalline Silicon PV Modules in Open-circuit or Maximum Power Point Conditions

11:00 COFFEE BREAK

11:30 SESSION ON MATERIALS, TECHNOLOGIES AND DEVICES CHAIRPERSON: B. Malič

11:30 Z. Šorn, B. Mušič, N. Rajnar, N. Figar

Effect of the Concentration of Tetraethyl Orthosilicate on Physical Properties of SiO_2 Aerogel, Incorporated into Melamine Substrate and Dried at Ambient Pressure

11:45 B. Bertoncelj, K. Vojisavljević, J. Rihtaršič, G. Jelenc, B. Malič

Characterization of Glass Fiber Reinforced Composites for Housing of Electrical Motors

12:00 A.-P. Abellard, D. Kuščer, M. Lethiecq,

J.-M. Grégoire, B. Malič and F. Levassort

Lead Zirconate Titanate Multi-element Structure by Electrophoretic Deposition

12:15 N. Jelić, L. Kos, J. Krek, J. Kovačič, T. Gyergyek, A. J. Christlieb, J. P. Verboncoeur

Ionization Front in a Gas-filled Diode During Electrical Breakdown

12:30 T. Gyergyek, J. Kovačič, N. Jelić, L. Kos

Sheath Formation in Front of a Negative Electrode Close to Plasma Potential Studied by PIC Simulations

12:45 S. Bernik, M. Pribošek

Construction and Characteristics of a Z-meter Setup for Thermoelectric Measurements of Materials

13:00 LUNCH

15:00 SESSION ON SENSORS AND MEMS CHAIRPERSON: S. Amon

15:00 D. Resnik, D. Vrtačnik, U. Aljančič, M. Možek, T. Dolžan,
B. Pečar, A. Janež, V. Urbančič, S. Amon
Microfabricated Si Microneedle Array for in Vitro Skin Penetration

15:15 D. Vrtačnik, D. Resnik, U. Aljančič, M. Možek,B. Pečar, T. Dolžan and S. AmonFabrication of Silicon Microneedles for Transdermal Drug Delivery

15:30 E. K. Juvan, T. Dolžan, B. Pečar, U. Aljančič, M. Možek, D. Vrtačnik, D. Resnik, S. Amon

Development of a Dry Etching System using Xenon Difluoride

15:45 B. Pečar, D. Križaj, D. Vrtačnik, D. Resnik, M. Možek, U. Aljančič, T. Dolžan, S. Amon Influence of an Excitation Signal Waveform on Micropump Operation - Numerical Simulation Analysis

16:00 T. Dolžan, D. Vrtačnik, D. Resnik, U. Aljančič, M. Možek,B. Pečar, S. AmonAutomated Characterization of Micropumps

16:15 COFFEE BREAK

16:45 M. Mraović, A. Pleteršek, T. Muck, U. Bogataj, M. Đokić Performances of the Screen Printed Capacitive Humidity Sensors on Recycled Paper and Cardboard

17:00 U. Aljančič, R. Bošnjak, M. Benedičič, D. Resnik, D. Vrtačnik, T. Dolžan, B. Pečar, M. Možek, S. Amon Photoplethysmograph Prototype for Clinical Use

17:15 G. Batistell and J. Sturm

Simulation and Implementation of a Filter-less CMOS Color Detector

17:30 M. Pavlović, M. Santo Zarnik, S. Kocjan, M. Stušek, D. Belavič Preliminary Media-compatibility Tests for LTCC-based Pressure Sensors

17:45 G. Matič, M. Jankovec, D. Jurman, M. Topič Tilt Determination Procedure for All-rotating Unmanned Aerial Vehicles

18:30 THE BUS DEPARTURE FROM HOTEL LARIX

19:00 VISIT AND WELCOME PARTY AT ALPINE MUSEUM IN MOJSTRANA

THURSDAY, SEPTEMBER 26

08:00 REGISTRATION

08:45 WORKSHOP ON DIGITAL ELECTRONIC SYSTEMS - OPENING

09:00 WORKSHOP – INVITED PAPERS CHAIRPERSON: A. Trost

09:00 P. Bulić

Fixed Point Multiplication and Division in the Logarithmic Number System: the Way to Low-power Design

09:45 A. Biasizzo On-line Testing and Recovery of Systems with Dynamic Partial Reconfiguration

10:30 COFFEE BREAK

11:00 F. Brglez

On Self-avoiding Walks across n-dimensional Dice and Combinatorial Optimization: An Introduction

11:45 J. Rodrigues

Design Aspects for Ultra-low Voltage Circuits

12:30 LUNCH

14:30 WORKSHOP – INVITED PAPERS CHAIRPERSON: A. Trost

14:30 D. Strle, J. Trontelj Signal Processing for Integrated, High Performance, Low Noise Chemical/Biological Sensor Interface

15:15 Z. Brezočnik Spin Model Checking Using SpinRCP

16:00 COFFEE BREAK

16:30 SESSION ON ELECTRONICS

CHAIRPERSON: D. Strle

16:30 A. Sešek, J. Trontelj Measurement System for Sea Wave Monitoring

16:45 P. Kogej

New Approaches in Magnetic Absolute Position Encoding

17:00 M. Kočevar

The Effect of Number of Scratches on Fingerprint Image Distortion and Efficiency of Fingerprint Image Enhancement

17:15 I. Fajfar, Á. Bűrmen Understanding Memristors

17:30 M. Celestina, A. Trost Hardware Implementation of 1/1 and 1/3 Octave Band Filters

17:45 J. Podržaj, J. Trontelj

Design for Improved Reliability of the Three Phase Motor Power Module

18:00 G. Ergaver, J. Trontelj Conducted and Radiated Emissions Characterization and Mitigation of Direct Current Brush-commutation Motor

18:15 M. Podhraški, J. Podržaj, J. Trontelj

The Impact of Solder Voids on Thermal Performance of a Power Module: A Numerical Evaluation

19:30 CONFERENCE DINNER AT LARIX RESTAURANT

FRIDAY, SEPTEMBER 27

08:00 REGISTRATION

08:45 INVITED PAPER CHAIRPERSON: M. Hrovat

8:45 I. Muševič

Integrated and Topological Liquid Crystal Photonics

09:30 SESSION ON THICK AND THIN FILMS CHAIRPERSON: M. Hrovat

09:30 M. Vrabelj, H. Uršič, B. Rožič, Z. Kutnjak, S. Drnovšek, B. Malič Electrocaloric Properties of 0.7Pb(Mg_{1/3}Nb_{2/3})O₃-0.3PbTiO₃ Ceramics Prepared from Mechanochemically Activated Powder

09:45 T. Pečnik, S. Glinšek, B. Kmet, R. C. Frunză, B. Malič Solution Derived $Ba_{0.5}Sr_{0.5}TiO_3$ Thin Films on Polycrystalline Alumina Substrates

10:00 R. C. Frunză, B. Kmet, K. Rachut, M. Jankovec, M. Topič, A. Klein and B. Malič Solution-derived Ta₂O₅-based Dielectric Thin Films for Transparent Electronic Devices

10:15 R. Rudež, S. Bernik

Studies of Concentrated Inks for the Screen Printing of Thick-film Varistors

10:30 G. Dolanc, D. Belavič, M. Hrovat, P. Fajdiga, S. Hočevar, A. Pohar, K. Makarovič System with Ceramic LTCC Micro-reactor for Steam Reforming

10:45 M. Hrovat, D. Belavič, K. Makarovič "Green" Thick Film Resistors on Various Substrates

11:00 M. Drev, U. Opara Krašovec, M. Topič Sol-gel Processed Down-converters for DSSC

11:15 COFFEE BREAK

11:45 SESSION ON INTEGRATED CIRCUITS and SYSTEM ON CHIP

CHAIRPERSON: J. Trontelj

11:45 U. Nahtigal, D. Strle Interface Circuitry for High Accuracy Optical Detection Systems

12:00 B. Šmid, J. Trontelj Extended Design of Integrated Micro-coil for Onboard Magnetic Field Generation

12:15 M. Trifković, D. Raič, D. Strle Serial Clock Tree Synthesis Based on Adjacency Matrix Manipulation

12:30 S. Starašinič A PICC to PCD Decoder Based on ISO 14443A - 106 kbit/s Bit Rate

12:45 R. Ribnikar, D. Strle Generating High Accuracy Signal with a Digital Oscillator

13:00 D. Štraus and A. Pleteršek Amplitude Modulated Backscattered Signals in Reader's RF Front-end

13:15 CLOSING CEREMONY